OFFICIAL

#### PATENT APPLICATION

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: 005651 USA/ETCH/CHMBR/JB1

Michael BARNES, et al.

RECEIVED

Appln. No.: 09/834,343

Group Art Unit: 1763

Confirmation No.: 2414

Filed: April 12, 2001

Examiner: A Crowell

For: PLASMA REACTOR ELECTRODE

# AMENDMENT UNDER 37 C.F.R. § 1.114(c)

### MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 11, 2003, please amend the above-identified application as follows on the accompanying pages.

## TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS
REMARKS5